

Study of Dense Plasma-Surface Interaction by a Filippov type Plasma Focus Device

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Received on 5 March, 2008

In this paper we have tried to investigate of dense plasma-material interaction in a Filippov type plasma focus (90KJ, 25KV, 288 μ f) facility. Dense plasma focus discharges are known as a remarkable source of hot plasma bunches and fast streams, fast neutrons, hard and soft X-rays, and energetic particles such as ions and electrons. The Aluminum made targets with 20cm in diameter and thickness 5mm, were placed at the central part of plasma focus cathode. These targets were exposed to perpendicular dense high temperature plasma stream incidence. The working gases for these experiments were Argon, Deuterium +Krypton, Helium, and pure Deuterium. We took advantage of changeable targets surface and used SEM technique for analyzing irradiated samples by various working gases. As it shown from SEM pictures and surface profiles, melt layer erosion by melt motion, surface smoothing, and bubble formation were some of different effects caused by diverse working conditions.

Keywords: Plasma focus; Plasma-wall interaction; Bubbling effect; Melt layer motion; Surface smoothing

I. INTRODUCTION

The dense plasma focus (DPF) devices were developed in the early 1960s as a modification of the classical Z-pinch by J. W. Mather in the USA and N. V. Filippov in former soviet union. It is a device which produces an electrical discharge in a rarefied gas with current that can vary, according to the energy and working voltage, from a few kA to several MA. Studies of the DPF have shown that a plasma of density 10^{25} m⁻³ and temperature 1keV can be achieved in a hot current carrying filament a few millimeters in diameter and about a centimeter in length. Plasma focus discharges are known as a remarkable source of hot plasma bunches and fast streams, fast neutrons proceeding from deuterium reactions, hard and soft X-rays, coming from different gases and the anodes in the discharge chamber, and energetic particles such as ions and electrons due to $m=0$ instabilities which may produce disruptions in plasma column for several nanoseconds. The spatial charge separation as well as the rapid change in the system inductance can generate strong electric fields that accelerate ions toward the top of the chamber and electrons toward the positively charged anode[1-5]. One of the main issues in the field of nuclear fusion research is the engineering design of structural materials. Since the plasma focus is a cost efficient and user friendly device, it allows one to simulate the plasma-material interaction studies of tokamaks and these studies are of importance for nuclear researches. In this study we have tried to investigate the behavior of plasma – Aluminium target interaction in DENA plasma focus facility.

II. EXPERIMENTAL SET-UP

DENA is a Filippov type plasma focus facility, with a capacitor bank of 288 μ F, a maximum supplied energy 90KJ(at $V_{max}=25$ KV) and giving a peak discharge current of about 2.8MA. Its anode is a disk of copper, with a diameter of 48cm, radius of 25cm, and a relatively easy changed anode inserts at it's center. It is isolated from the cathode by a cylindrical

porcelain insulator with a height of 12cm, and a diameter of 48cm. Lateral wall of cathode is made of stainless steel. Upper cover of the cathode is a disk of aluminium with a diameter of 75cm. There is an orifice in the center of this cover, with an aperture with a diameter of 20cm. This orifice is closed by a 5mm thick Aluminium target that has been placed in front of the anode surface at the distance of 12cm[6]. Chamber volume is about 61000cm³. The DENA facility scheme, and a picture of this device are shown in Fig. 1.

III. EXPERIMENTS

Aluminium targets with 20cm in diameter and thickness 5mm, were placed at the central part of cathode(it shown in Fig.1). These targets were exposed to perpendicular dense high temperature plasma stream incidence. For all shots investigated in this study, the device was operated at 16kV and the pressure varied from 0.8 to 1 torr. The working gases for these experiments were Argon with 100 shots, pure Deuterium with 100 shots, and Deuterium+%2 Krypton with 200 shots.

The discharge current and the current derivative were measured by Rogowski coil and magnetic probe, respectively. Fig. 2 displays typical current derivative signal of DENA plasma focus. It is accepted that the negative peak of current derivative, corresponds to the minimum pinch diameter.

In Fig. 3 pin-hole Soft X-ray (SXR) images taken during discharges with Ar, D₂, and D₂+%2Kr are shown. These images suggest the existence of a homogeneous plasma column that we need for reliable investigation.

We used scanning electron microscopy (SEM) techniques for analysing irradiated samples. Fig. 4 shows SEM images of Aluminium samples before and after plasma actions. In Fig. 5 images of Al targets are shown.

A profilometer was used for analysis of the surface of the melt layer. In Fig. 6 the profile of the melt surface using Ar filling gas are shown for perpendicular hot dense plasma exposure.

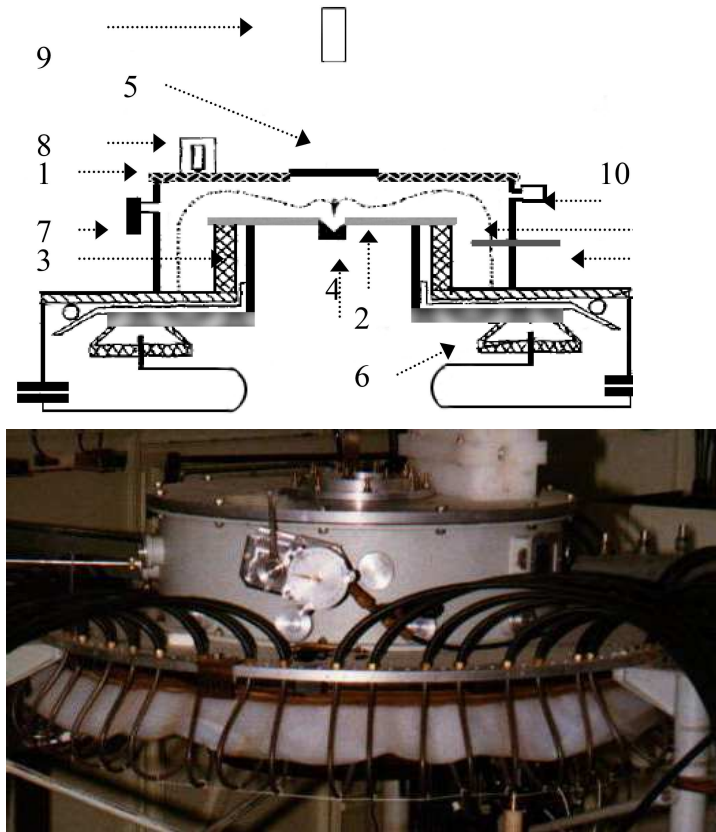


FIG. 1: Scheme(left) and a picture(right) of the DENA facility : 1-discharge chamber; 2-anode; 3- insulator; 4-anode insert; 5-Aluminium target; 6-vacuum spark gap; 7-semiconductor detector; 8-neutron detector; 9-vacuum diode with NaI scintillator; 10-pin-hole camera; 11-plasma current sheath; 12-magnetic probe; 13-capacitor energy storage.

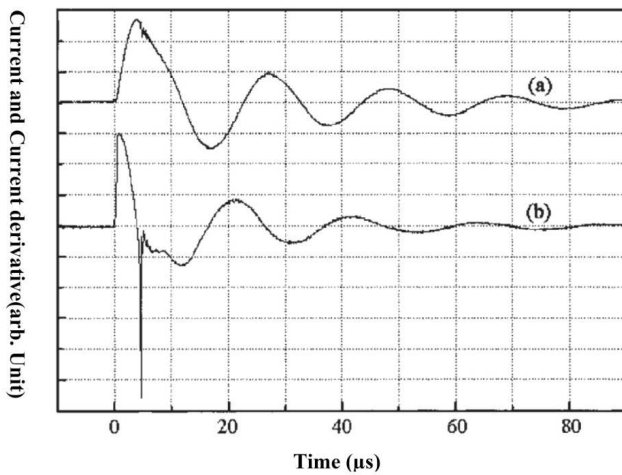


FIG. 2: Typical current (a) and current derivative (b) signals of the DENA plasma focus.

IV. EXPERIMENTAL RESULTS

As shown in Fig. 3, the observation over compression zone localization in space is attained with a pin-hole camera. Darker images can be clearly observed, which correspond to

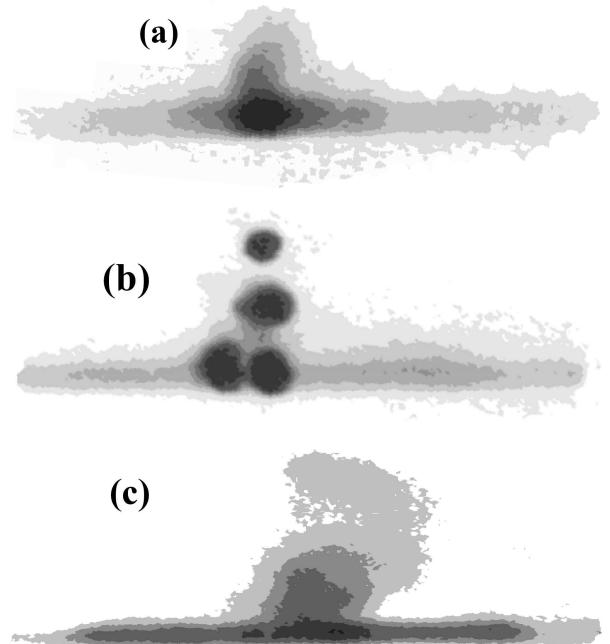


FIG. 3: SXR images obtained using a pin-hole camera: Ar (a), $D_2+2\%Kr$ (b), and D_2 (c).

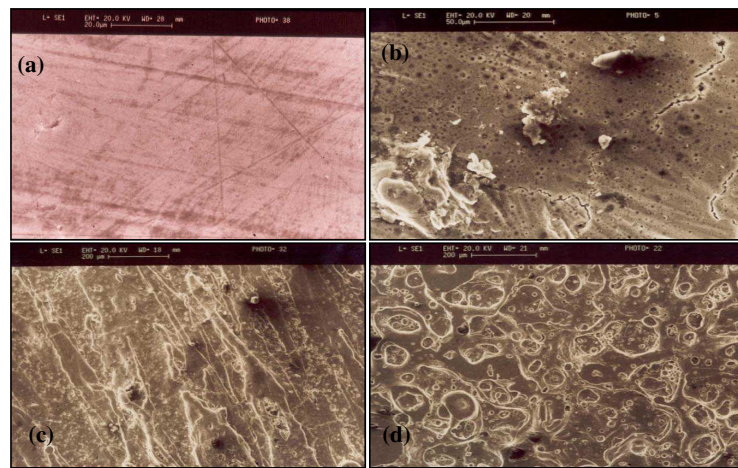


FIG. 4: SEM images of Aluminium samples. Before plasma exposure (a); after plasma exposure with Ar (b); D_2+2Kr (c); and D_2 (d).

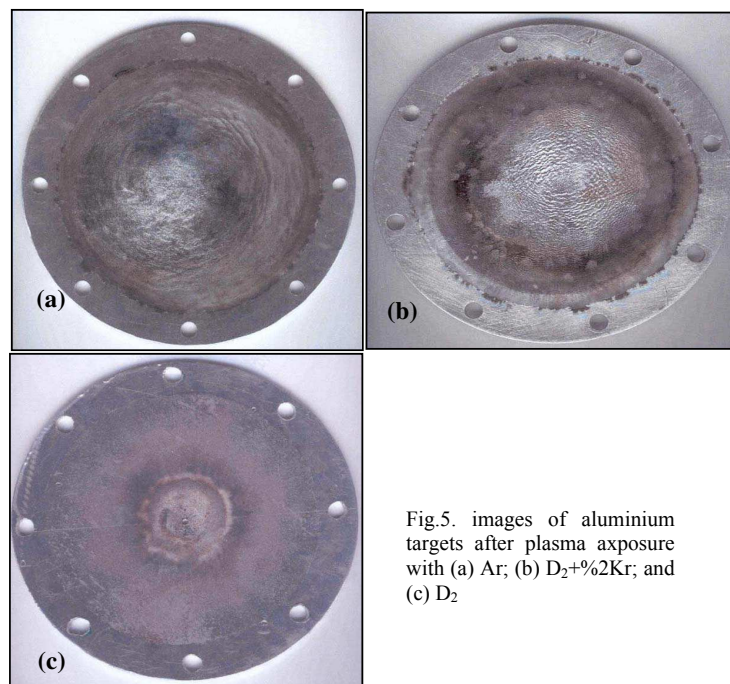


Fig.5. images of aluminium targets after plasma exposure with (a) Ar; (b) D_2+2Kr ; and (c) D_2

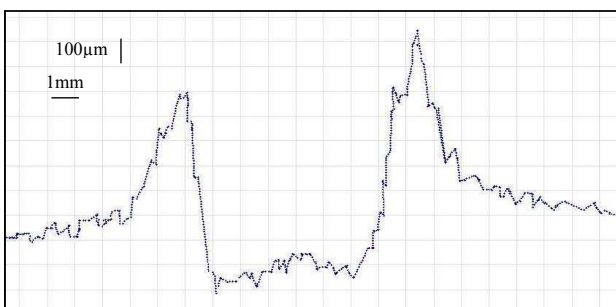


FIG.6: Al melt layer profile irradiated after 80 shots of Ar.

the higher intense irradiating streams. Inside the pinch column, practically when admixtures of Deuterium and Krypton

are applied, miniature regions of high density and high temperature plasma are formed (Fig. 3.b). Experiments show that “hot spots” lead to enhanced neutron yield [7].

The current sheath after and before pinch phase contact the electrodes and leads to erosion of aluminium target. The strongly displayed phenomena of melting, microcracks, evaporation, and sputtering of the surface layer have been registered in our experiments. As shown in Figs. 4.b, 5.a, 4.c, and 5.b, using Ar and D_2+2Kr as the working gases with 100 and 200 shots respectively, interaction of intense plasma streams with Aluminium targets results in the formation of a melt layer. The melt layer is subjected to different forces, which can lead to liquid metal splashing and macroscopic erosion. These experiments were also made by other researches, and have shown that metal erosion is dominated by melt mo-

tion. When the high voltage pulse is applied an azimuthal symmetric electrical discharge will be initiated and due to the $J \times B$ force the current is lifted off in an inverse pinch manner and plasma pressure gradient has its maximum value in the central part of target. The most pronounced melt motion is registered in the region of the maximum gradient of pressure [8]. Macroscopic motion of the melt layer and surface cracking are the main factors responsible for Aluminium target erosion. Our experiments show that etching of aluminium surface is noticeable in the central part of target. It is difficult to determine an erosion crater because of the large roughness of the surface. As shown in Fig.6 the crater with a maximum depth of $200\mu\text{m}$, and the diameter of about 8.5mm is observed close to the mountains. A considerable roughness is observed at these regions. The melt layer is subjected to external forces such as surface tension, gradients of plasma pressure and others. Melt motion driven by external forces produces significant macroscopic erosion of materials[5].

Surface smoothing was shown in Figs. 5.a and 5.b, using Ar and $\text{D}_2 + 2\text{Kr}$ plasma ion beams. These cluster beams are able to deliver energy of plasma ions to a target and redirect their motion along the surface. This result in a smoothing of the surface as depressions are filled with material transported from surface protrusions [9].

Bubble expansion and bubble collapse are illustrated in

Figs. 4.c and 4.d, for example. When D_2 ions strike the first wall, they penetrate to a given depth and come to rest. If the irradiation dose is high enough, these atoms coalesce to form bubbles [10]. On the other hand, as shown in Fig. 4.c, adding Krypton admixture to the Deuterium working gas lead to collapsing bubbles and greater surface damage.

V. CONCLUSION

In this article the results of experimental investigation of melt layer macroscopic erosion, bubbling effect, and surface smoothing are presented, using Ar and $\text{D}_2 + 2\text{Kr}$ as working gases, under irradiation the strong melting and droplet splashing with redeposition of splashed materials at the surfaces in the neighborhood of the melted area were clearly identified. The wavy structure at the surface of the melt layers and mountain formation were determined as a result of plasma pressure gradient by hot plasma bunches and powerful radiation after and before current disruption in plasma focus. Irradiation of sample with D_2 and $\text{D}_2 + 2\text{Kr}$ lead to bubble formation. Collapsing bubble in Fig. 4.c is due to adding Krypton admixture to the Deuterium working gas. Surface smoothing in Figs. 5.a and 5.b was illustrated using Ar and Kr gases.

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